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APPLICATION NO.	FILING	DATE	FIRST NAMED INVENTOR		ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/619,033 07/10/2003		2003	Lixin Zhao		6392		
	90	05/14/2004			EXAM	INER	
Lixin Zhao 43454 Bryant S	t.	*			BREWSTER,	REWSTER, WILLIAM M	
Fremont, CA		•			ART UNIT	PAPER NUMBER	
					2823		
	-		7	•	DATE MAILED: 05/14/200		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Applicati n	Ν.	Applicant(s)	
Offic Action Comments	10/619,033		ZHAO, LIXIN	
Offic Action Summary	Examiner		Art Unit	<u> </u>
	William M. Br		2823	AN
The MAILING DATE of this communical Period for Reply	tion appears n the c	ver sheet with the c	rrespondence addr	ess
A SHORTENED STATUTORY PERIOD FOR THE MAILING DATE OF THIS COMMUNICA - Extensions of time may be available under the provisions of 3 after SIX (6) MONTHS from the mailing date of this communic - If the period for reply specified above is less than thirty (30) da - If NO period for reply is specified above, the maximum statuto - Failure to reply within the set or extended period for reply will, Any reply received by the Office later than three months after earned patent term adjustment. See 37 CFR 1.704(b)	TION. 7 CFR 1.136(a). In no event, ation. rys, a reply within the statutory period will apply and will explicate the applicate the applicate.	nowever, may a reply be tim minimum of thirty (30) day; pire SIX (6) MONTHS from	nely filed s will be considered timely. the mailing date of this comi	munication.
Status	• •	· ·	·	
1)⊠ Responsive to communication(s) filed o	n <i>10 July 2003</i>			
	☑ This action is non-	final		
3) Since this application is in condition for			secution as to the m	nerite is
closed in accordance with the practice is				
Disposition of Claims				
4)⊠ Claim(s) <u>1-11,13 and 14</u> is/are pending	in the application			
4a) Of the above claim(s) is/are v	· •	deration		
5) Claim(s) is/are allowed.		20141011.		
6) Claim(s) 1-11,13 and 14 is/are rejected				•
7) Claim(s) is/are objected to.			•	
8) Claim(s) are subject to restriction	and/or election requ	irement.		
	1			.•
Application Papers			•	
9) The specification is objected to by the Ex				
10) The drawing(s) filed on is/are: a)				
Applicant may not request that any objection			• •	
Replacement drawing sheet(s) including the				
11) The oath or declaration is objected to by	the Examiner. Note	he attached Office	Action or form PTO	-152.
Priority under 35 U.S.C. § 119		`		
12) Acknowledgment is made of a claim for	oreign priority under	35 U.S.C. § 119(a)	-(d) or (f).	<u>(</u> -
a) ☐ All b) ☐ Some * c) ☐ None of:				•
1. Certified copies of the priority doc				
2. Certified copies of the priority doc				
3. ☐ Copies of the certified copies of the			d in this National St	age
application from the International	•	44 //	•	
* See the attached detailed Office action fo	r a list of the certified	copies not received	d.	
Attachment(s)		¥		
1) Notice of References Cited (PTO-892)		Interview Summary (PTO_413\	
2) Notice of Draftsperson's Patent Drawing Review (PTO-9	148)	Paper No(s)/Mail Dat	e	
3) Information Disclosure Statement(s) (PTO-1449 or PTO Paper No(s)/Mail Date	/SB/08) 5) [6) [Notice of Informal Pa	tent Application (PTO-15	52)
U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04)	ffice Action Summary	P	art of Paper No./Mail Da	te 051204

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DETAILED ACTION

Claim Objections

Claims 9, 11, 13, 14 are objected to because of the following informalities: end of sentence punctuation is nonexistent or incorrect. Appropriate correction is required.

The numbering of claims is not in accordance with 37 CFR 1.126 which requires the original numbering of the claims to be preserved throughout the prosecution. When claims are canceled, the remaining claims must not be renumbered. When new claims are presented, they must be numbered consecutively beginning with the number next following the highest numbered claims previously presented (whether entered or not).

Misnumbered claims 13 and 14 should be renumbered 12 and 13. Appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 6, 9 are rejected under 35 U.S.C. 102(b) as being anticipated by Lee, GP Publication No. 2,240,429 A.

Lee anticipates a method of forming an image sensor, comprising: in fig. 6, starting a substrate N- sub, with a first conductive type of semiconductor material; and

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forming a semiconductor layer on the substrate, P-EPI Layer, which has a second conductive type; and the second conductive type is opposite to the first conductive type and a PN junction is formed in the interface;

limitations from claim: 3, further comprising: forming a photodiode element, the photodiode element PD having a first well region, N+, of said first conductive type formed in said second conductive type semiconductor layer, a second well region, P+, of said second conductive type formed in said second conductive type semiconductor layer but higher doping density compare with said second conductive type semiconductor layer; and the said second well region surround the said first well' region at first distance, P+ at the left side of fig. 6, and form lateral PN junction and the said first well region to said second conductive type semiconductor layer form vertical PN junction, N+ to P-EPI Layer, limitations from claim 6: further comprising: forming latch up preventing deep well, a deep well is formed at third center depth and first thickness in said second conductive semiconductor layer below standard N well and standard P well with said second conductive type doping in sensor accessory circuit area to prevent latch up happen, wherein applying the merger doctrine, Lee uses the top part of the well as the first well and the lower part as the latch-up preventing well; limitations from claim 9: wherein the said first conductive type semiconductor is N type substrate, the said conductive second type semiconductor material layer is a P- type epitaxial layer, p. 3, ¶ 2.

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 2, 3, 4, 5, 7, 10, 11, 13, 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee as applied to claims 1, 6, 9 above, and further in view of Applicant's Admitted Prior Art.

Lee does not specify integration of the photodetector with a CMOS configuration, AAPA does. AAPA in fig. 1, teaches the said first well region can be realized by the standard well forming in standard CMOS process, the left side of the diagram, with said first conductive type semiconductor; or realized by the standard CMOS well stacked with a deep well 110, 114 with said first conductive type semiconductor; and the said second well region can be realized by the standard well forming in standard CMOS process with said second conductive type semiconductor; or realized by the standard CMOS well stacked with a deep well with said second conductive type semiconductor, Background of Application. Although applicant suggests the type of device used by Lee would not typically be compatible, the configuration of Lee, fig. 6 has similar layer configurations to the photodiode of fig. 1. Further atypical configuration, does not rule out the configuration entirely.

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Lee teaches limitations from claim 2: the first conductive type semiconductor substrate and the second conductive type semiconductor layer are connecting to different voltage and the said PN junction is reversing biased, in fig. 6, the symbol for the voltage difference is drawn on the bottom and to the right of the diagram for reverse biasing, and AAPA also teaches reverse biasing on p.1, ¶ 2, of the Background. The AAPA gives motivation on p. 2, ¶ 3. It would have been obvious to a person of ordinary skill in the art at the time the invention was made to recognize that combining AAPA's process with Lee's invention would have been beneficial because It would have been obvious to a person of ordinary skill in the art at the time the invention was made to recognize that combining AAPA's process with Lee's invention would have been beneficial because the CMOS provides logic control circuits.

For claims 4, 5, 7, 13, and 14, Lee does not specify the distances between, the depth, the thicknesses, and the doping densities, of his regions, but the practitioner may optimize these parameters.

"Normally, it is to be expected that a change in temperature, or in concentration, or in both, would be an unpatentable modification. Under some circumstances, however, changes such as these may impart patentablility to a process if the particular ranges claimed produce a new and unexpected result which is different in kind and not merely degree from the results of the prior art . . . such ranges are termed 'critical ranges' and the applicant has the burden of proving such criticality . . . More

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particularly, where the general conditions of a claim are disclosed in the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentation."

In re Aller 105 USPQ 233, 255 (CCPA 1955). See also In re Waite 77 USPQ 586 (CCPA 1948); In re Scherl 70 USPQ 204 (CCPA 1946); In re Irmscher 66 USPQ 314 (CCPA 1945); In re Norman 66 USPQ 308 (CCPA 1945); In re Swenson 56 USPQ 372 (CCPA 1942); In re Sola 25 USPQ 433 (CCPA 1935); In re Dreyfus 24 USPQ 52 (CCPA 1934).

Note that the specification contains no disclosure of either the critical nature of the claimed dimensions of any unexpected results arising there from. Where patentability is aid to be based upon particular chosen dimensions or upon another variable recited in a claim, the Applicant must show that the chosen dimensions are critical. In re Woodruff, 919 F.2d 1575, 1578, 16 USPQ2d 1934, 1936 (Fed. Cir. 1990).

Claims 8, 10, are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee as applied to claims 1, 6, 9 above, and further in view of Nakashiba, U.S. Patent No. 6,472,698.

Lee does not specify planarizing a top oxide, but Nakashiba does. Nakashiba teaches, in fig. 4B, wherein the said first conductive type semiconductor is P type substrate 1, the said second conductive type semiconductor material layer is a N- type epitaxial layer, 4, a well-known practice to invert the charging types for device manufacturing, col. 1, line 61 - col. 2, line 14; growing a top oxide layer, referred to as 34 and 44, and after growing a top oxide layer, carrying out a process of chemical mechanical polishing (CMP), col. 4, lines 1-15. It would have been obvious to a person of ordinary skill in the art at the time the invention was made to recognize that

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combining Nakashiba's process with Lee's invention would have been beneficial because it has the correct height and flat surface to form microlens 35.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to William M. Brewster whose telephone number is 571-272-1854. The examiner can normally be reached on Full Time.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

12 May 2004

William M. B rewater

WB